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"Method for Forming Capacitor of Semiconductor

Device"

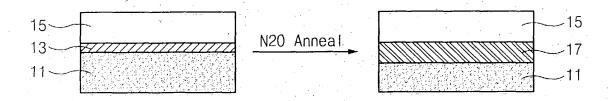


Fig.1 <Prior Art>

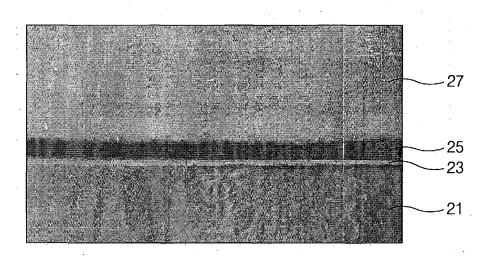


Fig.2 <Prior Art>

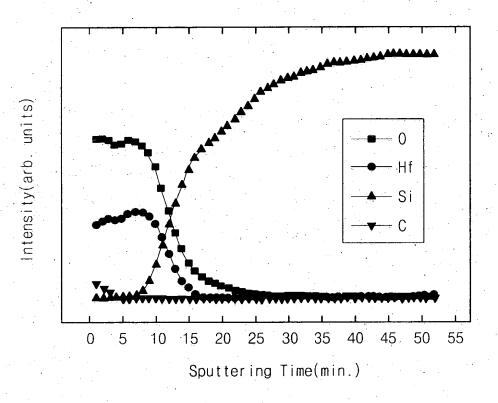


Fig.3a <Prior Art>

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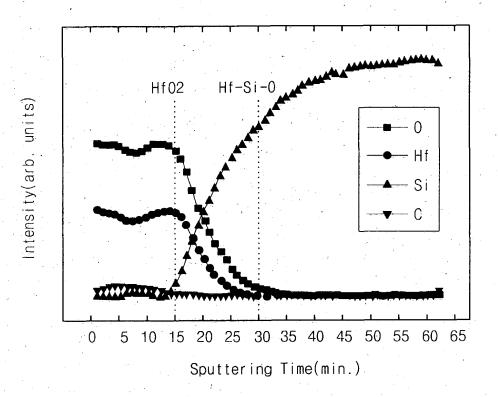


Fig.3b <Prior Art>

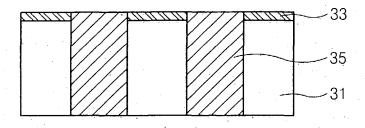


Fig.4a

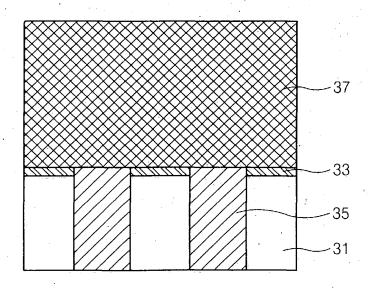


Fig.4b

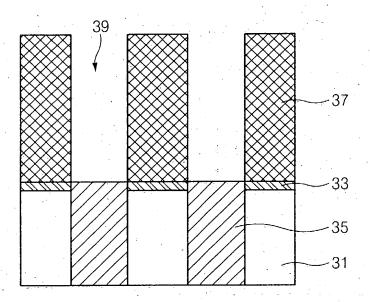


Fig.4c

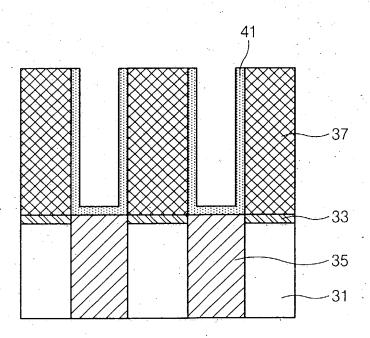


Fig.4d

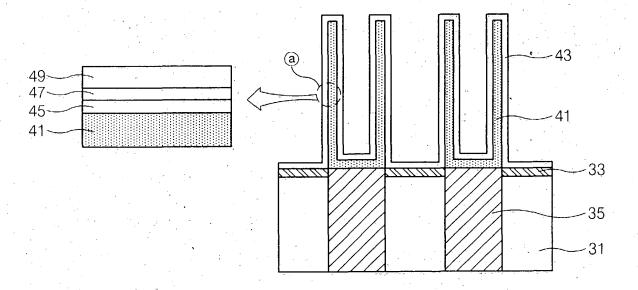


Fig.4e

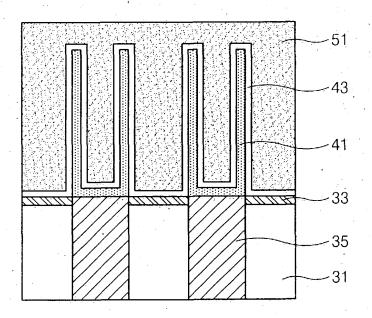


Fig.4f

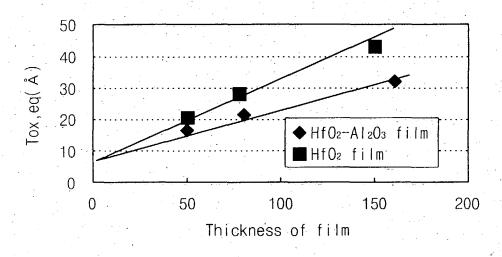


Fig.5